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Attorney Docket No.: P1054 – LAM (RAO)



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): **Zhu et al.**

Group art Unit: **2823**

Application Serial No.: **10/680,894**

Examiner: **Estrada, Michelle**

Filed: **October 8, 2003**

Title: **An Etch Back Process Using  
Nitrous Oxide**

**AMENDMENT AND RESPONSE TO OFFICE ACTION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir/Madam:

This Amendment and Response is submitted in response to the Office Action dated June 28, 2004 in the above referenced patent application. Please enter and consider the following amendments and remarks.

**Amendment to the Specification** are reflected on Page 2 of this paper

**Amendments to the Claims** are reflected in the listing of claims which begins on Page 3 of this paper.

**Remarks** begin on page 7.